

WEST Search History

DATE: Tuesday, January 09, 2007

Hide?	<u>Set</u> <u>Name</u>	<u>Query</u>	<u>Hit</u> <u>Count</u>
	<i>DB=PGPB,USPT; PLUR=YES; OP=ADJ</i>		
<input type="checkbox"/>	L24	L23 and l22	2
<input type="checkbox"/>	L23	134/94.1,95.2,99.1,102.1,102.3,105,107,902.ccls. (apparatus or chamber) same (wafer or semiconductor or substrate or article)	4288
<input type="checkbox"/>	L22	same pressur\$7 same temperature same (((releas\$3 or (fail shut) or bellow) with (valve or element)))	81
	<i>DB=USOC; PLUR=YES; OP=ADJ</i>		
<input type="checkbox"/>	L21	(apparatus or chamber or autoclave) same dry\$3 same (wafer or semiconductor or substrate or article) same (hold\$3 or support\$3 or chuck\$3) same pressur\$7 same temperature same (((releas\$3 or (fail shut) or bellow) with (valve or element)))	25
<input type="checkbox"/>	L20	(apparatus or chamber or autoclave) same dry\$3 same (wafer or semiconductor or substrate or article) same pressur\$7 same temperature same (((releas\$3 or (fail shut) or bellow) with (valve or element)))	60
	<i>DB=EPAB,JPAB,DWPI,TDBD; PLUR=YES; OP=ADJ</i>		
<input type="checkbox"/>	L19	(apparatus or chamber or autoclave) same dry\$3 same (wafer or semiconductor or substrate or article) same pressur\$7 same temperature same (((releas\$3 or (fail shut) or bellow) with (valve or element)))	1
	<i>DB=PGPB,USPT; PLUR=YES; OP=ADJ</i>		
<input type="checkbox"/>	L18	(apparatus or chamber or autoclave) same dry\$3 same (wafer or semiconductor or substrate or article) same pressur\$7 same temperature same (((releas\$3 or (fail shut) or bellow) with (valve or element)))	8
<input type="checkbox"/>	L17	(apparatus or chamber) same dry\$3 same (wafer or semiconductor or substrate or article) same pressur\$7 same temperature same (((releas\$3 or (fail shut) or bellow) with (valve or element)))	6
	<i>DB=EPAB,JPAB,DWPI,TDBD; PLUR=YES; OP=ADJ</i>		
<input type="checkbox"/>	L16	(apparatus or chamber) same dry\$3 same (wafer or semiconductor or substrate or article) same pressur\$7 same temperature same (((releas\$3 or (fail shut) or bellow) with (valve or element)))	1
	<i>DB=PGPB,USPT,USOC; PLUR=YES; OP=ADJ</i>		
<input type="checkbox"/>	L15	(apparatus or chamber) same dry\$3 same (wafer or semiconductor or substrate or article) same (hold\$3 or support\$3 or chuck\$3) same pressur\$7 same temperature same (((releas\$3 or (fail shut) or bellow) with (valve or element)))	28
	<i>DB=EPAB,JPAB,DWPI,TDBD; PLUR=YES; OP=ADJ</i>		
<input type="checkbox"/>	L14	(apparatus or chamber) same dry\$3 same (wafer or semiconductor or substrate or article) same (hold\$3 or support\$3 or chuck\$3) same pressur\$7 same temperature same (((releas\$3 or (fail shut) or bellow) with (valve or element)))	0

<input type="checkbox"/>	L13	(apparatus or chamber) same dry\$3 same (wafer or semiconductor or substrate or article) same (hold\$3 or support\$3 or chuck\$3) same pressur\$7 same temperature same (((releas\$3 or (fail shut)) with (valve or element)))	0
<input type="checkbox"/>	L12	(apparatus or chamber) same dry\$3 same (wafer or semiconductor or substrate or article) same (hold\$3 or support\$3 or chuck\$3) same pressur\$7 same temperature same ((releas\$3 or (fail shut) with (valve or element)))	0
<input type="checkbox"/>	L11	(apparatus or chamber) same (wafer or semiconductor or substrate or article) same (hold\$3 or support\$3 or chuck\$3) same pressur\$7 same temperature same ((releas\$3 or bellows or (fail shut) with (valve or element)))	25
<input type="checkbox"/>	L10	(apparatus or chamber) same (wafer or semiconductor or substrate or article) same pressur\$7 same temperature same ((releas\$3 or bellows or (fail shut) with (valve or element)))	102
<input type="checkbox"/>	L9	(apparatus or chamber) same (wafer or semiconductor or substrate or article) same pressur\$7 same ((releas\$3 or bellows or (fail shut) with (valve or element)))	651
<input type="checkbox"/>	L8	(apparatus or chamber) same (wafer or semiconductor or substrate or article) same pressur\$7 same (releas\$3 or bellows or (fail shut))	651
		<i>DB=USPT; PLUR=YES; OP=ADJ</i>	
<input type="checkbox"/>	L7	6896740.pn. or 5715612.pn.	2
		<i>DB=PGPB,USPT,USOC,EPAB,JPAB,DWPI; PLUR=YES; OP=ADJ</i>	
<input type="checkbox"/>	L6	L5 and ((chamber or apparatus) same heat\$3 same pressur\$7 same releas\$3)	6
<input type="checkbox"/>	L5	L4 or l1 or l2	17838
<input type="checkbox"/>	L4	(dainippon screen).as.	17838
<input type="checkbox"/>	L3	(danippon screen).as.	4
<input type="checkbox"/>	L2	ozaki-hidehiko\$.in.	8
<input type="checkbox"/>	L1	nagami-shuzo\$.in.	12

END OF SEARCH HISTORY